

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	(semiconductor and antifuse and vertical\$3 and stack\$3 and common and intermediate and source and drain and gate and electrode and upper and lower and insulat\$3).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/23 13:50